Docket No.: OGOSH44USA

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.

10/566,116

Confirmation No. 3700

**Applicant** 

: Akihisa Inoue et al.

371 Filed

January 24, 2006

Art Unit

1793

Examiner

Weiping Zhu

Customer No.

00270

Title

SPUTTERING TARGET AND METHOD FOR PRODUCTION

THEREOF

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

This is an Amendment submitted with a Request for Continued Examination (RCE) in response to a FINAL Office Action dated May 19, 2010. A Petition for a One Month Extension of Time to extend the deadline for response from August 19, 2010 to Monday, September 20, 2010 is filed herewith (September 19th being a Sunday with September 20th being the first business day following Sunday). Kindly amend the application as set forth below.

<u>Amendments to the Claims</u> are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.